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Innovativity To Productivity

PRODUCTIVE TECHNOLOGIES COMPANY LIMITED

普達特科技有限公司*

(Incorporated in Bermuda and continued in the Cayman Islands with limited liability)

(Stock Code: 650)

UPDATE ON DEVELOPMENT OF EQUIPMENT FOR SEMICONDUCTOR

This announcement is made by Productive Technologies Company Limited (the "**Company**") on a voluntary basis to keep the shareholders and potential investors of the Company informed of the latest business development of the Company.

Reference is made to the announcement of the Company dated July 23, 2025 in relation to the development of the equipment for semiconductor and solar power (the "**Announcement**"). Unless the context requires otherwise, the capitalized terms contained herein will have the same meanings as those defined in the Announcement.

RECEIPT OF EQUIPMENT EVALUATION AGREEMENTS

The Company has received equipment evaluation agreements for the OCTOPUS 12-inch single wafer cleaning equipment (the "**OCTOPUS Equipment**") from two high-quality semiconductor customers. One of the customers, a 12-inch wafer foundry, will purchase two OCTOPUS Equipment for critical cleaning steps in its 28nm process. The other customer, a 12-inch high-performance analog and power device fab, will purchase one OCTOPUS Equipment and one CUBE 6- to 12-inch single wafer cleaning equipment (the "**CUBE Equipment**"). In addition to the aforementioned orders, the Company recently received equipment evaluation agreements for three additional CUBE Equipment from power device customers, and one of which has already been delivered. Revenue from these evaluation agreements has not yet been recognized. To the best of the Directors' knowledge, information and belief, having made all reasonable enquiries, these Customers and its ultimate beneficial owners are third parties independent of the Company and its connected persons as at the date of this announcement.

The OCTOPUS single wafer cleaning equipment, independently developed by the Company, is benchmarked against leading global equipment suppliers. It is designed for large-scale 12-inch wafer production lines and covers key semiconductor cleaning processes such as Solvent, RCA, and backside cleaning. The equipment is standardly configured with 16 or 8 chambers. Through innovative designs such as the integration of the chemical supply system and process chambers, it enables higher productivity, more flexible process configurations, and lower costs, and provide customers with a more cost-effective solution. In terms of industrialization, the equipment has already received orders from multiple customers and has successfully passed acceptance tests. Going forward, the Company will continue to focus on fulfilling orders and ensuring successful acceptance of the equipment. The Company will also leverage the expertise of our technical team in semiconductor wet processing technology to expand the adoption of our equipment by high-quality semiconductor customers in critical application areas.

GENERAL

The transactions contemplated under the equipment evaluation agreements do not constitute notifiable transactions of the Company under Chapter 14 of the Rules Governing the Listing of Securities on The Stock Exchange of Hong Kong Limited. The Company will make further announcement(s) as and when appropriate if required.

The Shareholders and potential investors are advised to exercise caution when dealing in the securities of the Company.

By Order of the Board
Productive Technologies Company Limited
Liu Erzhuang
Chairman and Chief Executive Officer

Hong Kong, October 28, 2025

As at the date hereof, the Board comprises eight Directors, of whom three are executive Directors, namely Dr. Liu Erzhuang (Chairman), Mr. Tan Jue and Mr. Liu Zhihai; two are non-executive Directors, namely Mr. Cao Xiaohui and Mr. Lin Yukai; and three are independent non-executive Directors, namely Ms. Ge Aiji, Mr. Chau Shing Yim David, and Mr. Wang Guoping.

* *For identification purposes only*